

FEB 0 6 2006TRANSMITTAL OF FORMAL DRAWINGS

Docket No. BUR920020075US1 (16215)

In Resident from Of:

Kenneth A. Bandy, et al.

Application No.	Filing Date	Examiner	Customer No.	Group Art Unit	Confirmation No.
10/604,087	June 25, 2003	Lan Vinh	23389	1765	1086

Invention:

MULTI-RUN SELECTIVE PATTERN AND ETCH WAFER PROCESS

Address to:

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Transmitted herewith are:

5 sheets of formal drawing(s) for this application.

Each sheet of drawing indicates the identifying indicia suggested in 37 CFR Section 1.84(c).

Signature

Dated: February 2, 2006

Leslie S. Szivos, Ph.D.
Registration No. 39,394
Scully, Scott, Murphy & Presser, P.C.
400 Garden City Plaza, Suite 300
Garden City, New York 11530
516-742-4343

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to "Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450" [37 CFR 1.8(a)] on

February 2, 2006

(Date)

Signature of Person Mailing Correspondence

Leslie S. Szivos, Ph.D.

Typed or Printed Name of Person Mailing Correspondence